Fabrication of Microfluidic Devices for **Advanced Rheological** Measurements

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Organization: Oregon State University CBEE

Extensional Rheology

 Extensional viscosity is the measure of a fluid's resistance to an extensional stress.

- Used to measure properties of materials
 - Cosmetics
 - Inks
 - Biological fluids

Current Measurement Techniques

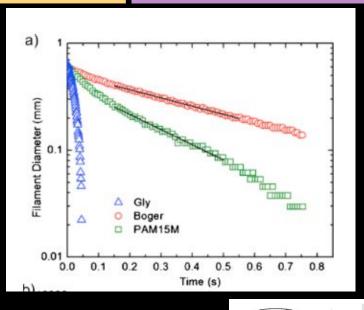
- CaBER
- RFX
- Microfluidics

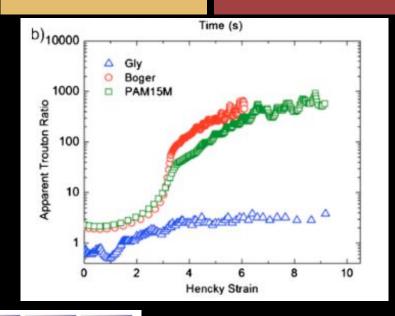


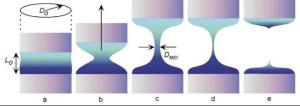




CaBER Data

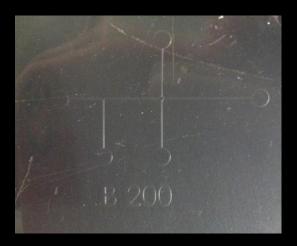






Current Measurement Techniques

- CaBER
- RFX
- Microfluidics







Microfluidics

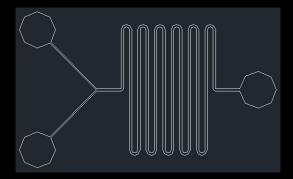
- Observing the flow of liquids at a small scale (nanometers and micrometers)
- Surface-to-volume ratio

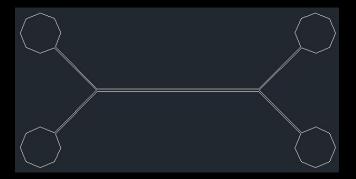
$$m\frac{dv}{dt}\sim\rho(L^3)+\tau(L^2)+\gamma(L)$$

- Scaling Phenomena
 - In microscale, inertial effects become insignificant relative to surface interactions

Applications of Microfluidics

- Chemical separation and analysis
- Medical diagnostics
- Microreactors
- Inkjet printers





Fabrication Techniques

- Photolithography
- Solidification or Reshaping
 - o Casting, Replica Molding, Hot Embossing, etc.
- Subtractive Processes
 - Etching, Laser Ablation, Abrasive Jet, etc.
- Additive Processes
 - Vapor Deposition, Electroplating, Contact Printing, etc.



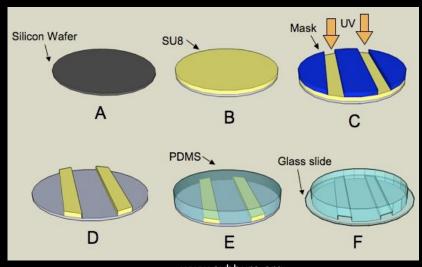
Photolithography/Soft Lithography

Photolithography

- Clean and heat the silicon wafer
- Apply the photoresist (spin coating)
- Pre-bake the photoresist
- Expose the photoresist to intense light
- Complete a post-exposure bake
- Apply the developer

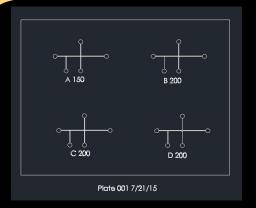
Soft lithography

- Pour and cure PDMS
- Use a UV Ozone machine to bond the PDMS to a glass slide



www.sybbure.org

Photolithography/Soft Lithography











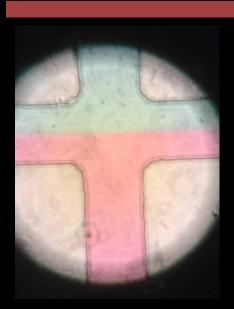


Setup of Devices

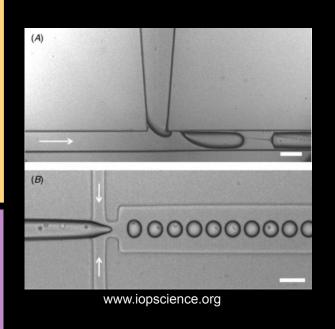
- Syringe Pumps
- Luer Connections
- Needles
- Direct Tubing





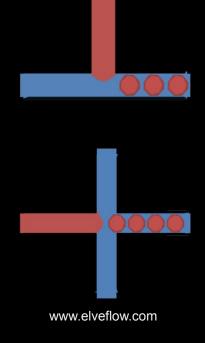


Droplet Formation

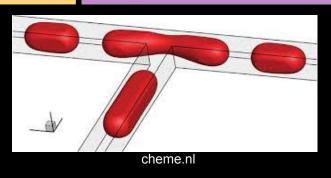


T-junction

Flow-focussing



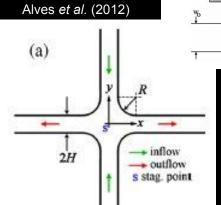
Measuring Extensional Viscosity



T-junction



Cross-slot



Anna et al. (2009)

Acknowledgements

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